

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Woo Sik Yoo
Assignee: WaferMasters, Inc.
Title: Gas-Assisted Rapid Thermal Processing
Serial No.: 10/005,827 Filing Date: November 8, 2001
Examiner: Trinh, M. Group Art Unit: 2822
Docket No.: M-11914 US

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PETITION FOR EXTENSION OF TIME

Dear Sir:

Applicant(s) respectfully petition(s) for a 2-month extension of time within which to respond to the Final Office Action mailed by the U.S. Patent and Trademark Office on May 5, 2004, such extension allowing the undersigned until October 5, 2004 to respond.

Please charge the fee of \$215.00 to the undersigned's Deposit Account No. 50-2257. Please charge any additional fees or credit overpayment to the above-deposit account. If there are any questions, please call the undersigned at (949) 752-7040.

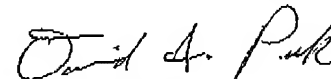
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I hereby certify that this correspondence is being facsimile transmitted to the U.S. Patent and Trademark Office to Fax No. 703-872-9306 on the date stated below.


Tina Kavanaugh

October 4, 2004

Respectfully submitted,


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